



Docket No.: 285995US26PCT



COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

ATTORNEYS AT LAW

RE: Application Serial No.: 10/567,733
Applicants: Kohei KAWAMURA, et al.
Filing Date: February 10, 2006
For: METHOD FOR FORMING FILM, METHOD FOR
MANUFACTURING SEMICONDUCTOR DEVICE,
SEMICONDUCTOR DEVICE AND SUBSTRATE TREATMENT
SYSTEM
Group Art Unit: 2823
Examiner: Kevin A. PAREDO

SIR:

Attached hereto for filing are the following papers:

RESPONSE TO RESTRICTION REQUIREMENT

Credit card payment is being made online (if electronically filed), or is attached hereto (if paper filed), in the amount of **\$0.00** to cover any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. **15-0030**. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time.

Respectfully submitted,

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